

## UNITED STATES PATENT AND TRADEMARK OFFICE

## Bib Data Sheet

**CONFIRMATION NO. 2965** 

SERIAL NUMBER 10/519,401	FILING OR 371(c)  DATE  01/04/2005  RULE	CLASS 134	GROUP ART	ROUP ART UNIT 1746		ATTORNEY DOCKET NO. 264189US3PCT	
Kazuya Dobash Mikio Suzuki, Ya Takashi Magara  ** CONTINUING DATA This application ZE  ** FOREIGN APPLICA JAPAN 2002-19	Yamanashi, JAPAN; i, Yamanashi, JAPAN; amanashi, JAPAN; amanashi, JAPAN; i, Yamanashi, JAPAN; is a 371 of PCT/JP03/0 ATIONS 17365 07/05/2002 i7945 12/10/2002	08317 07/01/2003					
Foreign Priority claimed  35 USC 119 (a-d) conditions  met  Verified and Acknowledged  Examiner's Signature  ADDRESS  22850		JAPAN	SHEETS DRAWING 19	AWING CLAII		INDEPENDENT CLAIMS 5	
TITLE  Method of cleaning substrate-processing device and substrate-processing device							
FILING FEE FEES RECEIVED No 2100 No	S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:			☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			